

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	2028388
<b>Application Number:</b>	10553720
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	6095
<b>Title of Invention:</b>	Photolithographic process, stamper, use of said stamper and optical data storage medium
<b>First Named Inventor/Applicant Name:</b>	Jacobus Hermanus Maria Neljzen
<b>Customer Number:</b>	24737
<b>Filer:</b>	Michael E. Belk/EDNA CHAPA
<b>Filer Authorized By:</b>	Michael E. Belk
<b>Attorney Docket Number:</b>	NL 030401
<b>Receipt Date:</b>	31-JUL-2007
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<b>Application Type:</b>	U.S. National Stage under 35 USC 371

### Payment information:

Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	NL030401_IDSFORM.pdf	780235 746a5e4d6157e039c743c7f860d4f6c67a8ee6f7	no	5

**Warnings:**

<b>Information:</b>					
2	Foreign Reference	EP0698825A1.pdf	681120 1576b1db7c2bae70bc38a41aacbb3a0a b5673a0b	no	13
<b>Warnings:</b>					
<b>Information:</b>					
3	NPL Documents	Application_of_polymethylmethacrylate_ultrathin_resist_supported.pdf	160323 d8c16ed93a193a33b0d1637b56a0c3789 23a0806d	no	2
<b>Warnings:</b>					
<b>Information:</b>					
4	NPL Documents	Potential_of_DNQ_novolac_and_chemically_amplified_resists_for.pdf	471500 a2251a269d4d7623c07115abd063429 75d14eae	no	8
<b>Warnings:</b>					
<b>Information:</b>					
5	NPL Documents	Ultrathin_polymethylmethacrylate_resist_films_for_micro lithography.pdf	471831 c61314af02d2a4a16dc7dbcd0aac0a2 047566a	no	7
<b>Warnings:</b>					
<b>Information:</b>					
6	NPL Documents	Ultrathin_resist_films_pattern ing_using_a_synchrotron.pdf	193535 460a902b0c44c8391b0c5c349f92a3 1008b17	no	3
<b>Warnings:</b>					
<b>Information:</b>					
<b>Total Files Size (in bytes):</b>			2758544		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><b>New Applications Under 35 U.S.C. 111</b>          If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><b>National Stage of an International Application under 35 U.S.C. 371</b>          If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><b>New International Application Filed with the USPTO as a Receiving Office</b>          If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					